



LIST OF ART CITED BY APPLICANT
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Janine K. Kardokus et al.

FILING DATE
December 19, 2001

GROUP
1742

U.S. PATENT DOCUMENTS

*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
SK	AA	4,189,084	02-1980	Johnson et al.	—	—
SK	AB	5,590,389	12-1996	Dunlop et al.	—	—
SK	AC	4,786,469	11-1988	Weber et al.	—	—
	AD					
	AE					
	AF					
	AG					
	AH					
	AI					
	AJ					
	AK					
	AL					

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FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
Q	AM	85104006	1986	China (abstract)	—	—		1
Q	AN	62036798	1987	Japan (abstract)	—	—		1
Q	AO	61227972	1986	Japan (abstract)	—	—		1
Q	AP	49007777	1974	Japan (abstract)	—	—		1
	AQ							

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)

AR	Reda et al., "Amorphous copper-silver films with high stability", Int. Cent. Theor. Phys., 1982. (Abstract)
AS	
AT	

EXAMINER

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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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